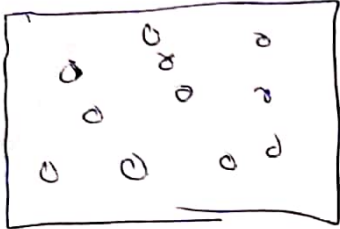


# Semiconductor Physics

Solid — atom — electron (outermost electron)

↓  
free electron (unpaired electron)

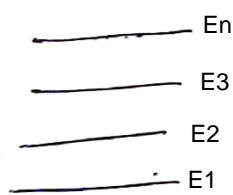
↓  
sea of electron (free electron gas)



→ [Quantum Mechanical analysis] → wave nature of electron motion

free electron theory (No-electron interaction,  $V = \text{const}$ )

Quantized energy states



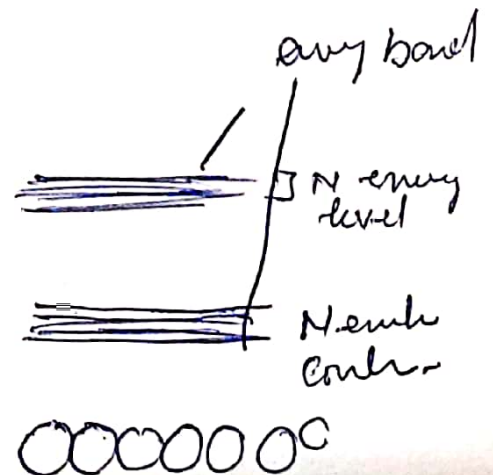
$$E_n = -13.6/n^2$$

Nearly free electron theory [Periodically varying potential]

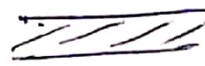
↓  
energy bands → forbidden energy states

↓  
Band gap

Band formation in solid



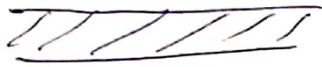
## Band formation of solids



— allowed energy states



out of all allowed states



\* Highest filled states at  $T=0K$  is called valence band  
\* lowest empty band is called conduction band

electrons are spin  $\cdot \frac{1}{2}$  particles, follow Pauli's exclusion principle; distribution follows Fermi-Dirac distribution.

How energy states are going to be filled

$[S = \frac{1}{2}, \frac{3}{2}, \dots$  particles called fermions]

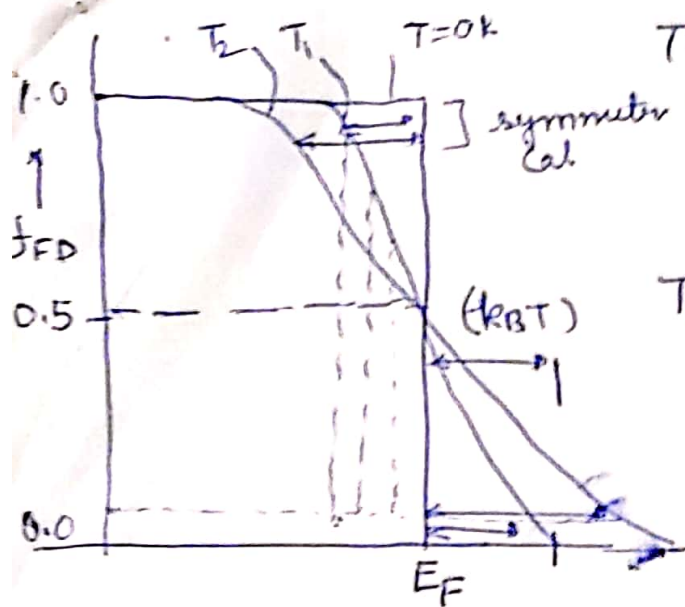
$[S = 0, 1, 2, \dots$  called Bosons]

## Fermi-Dirac Distribution function

$$f_{FD} = \frac{1}{1 + e^{(E-E_F)/k_B T}}, \quad f_{BE} = \frac{1}{e^{(E-E_F)/k_B T} - 1}$$

↓  
prob. that an energy level 'E' is filled.

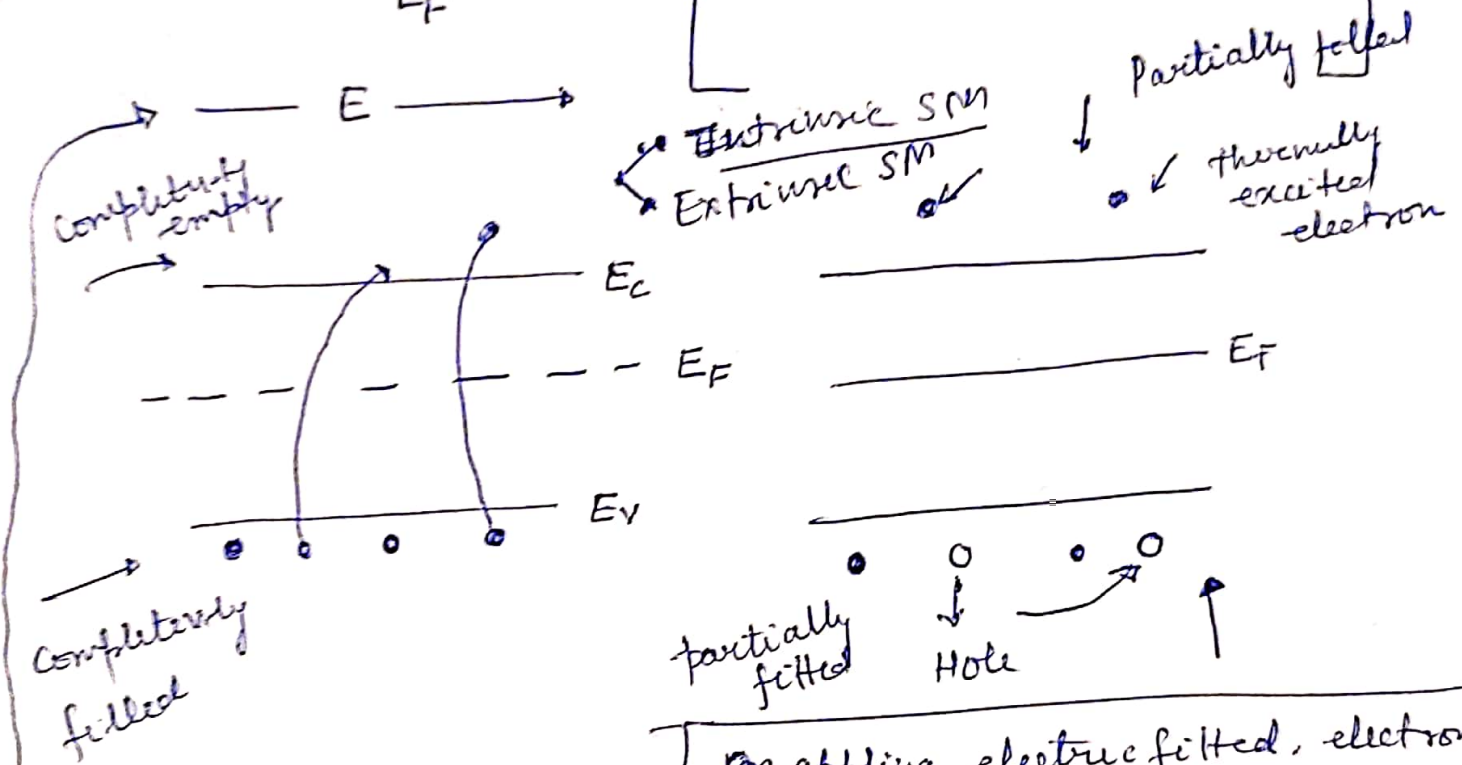
$E_F$  = fermi energy level, this may & may not represent energy level but used as reference point and very useful in explaining various characteristics of solids.



$T=0K$   
all energy levels below  $E_F$  are filled and all energy levels above  $E_F$  are empty

$T_1 (T_1 > 0K)$

some Numerical example.



$E_g = E_C - E_V = \text{Band gap}$   
 $E_g = 0$  Conductor  
 $E_g \sim$  Semiconductor  
 $E_g \text{ large}$  - insulator

On applying electric field, electron and hole moves into respective bands as the bands are partially filled. Motion of electron in opposite to external field while hole in direction of applied field. Thus motion of both charges

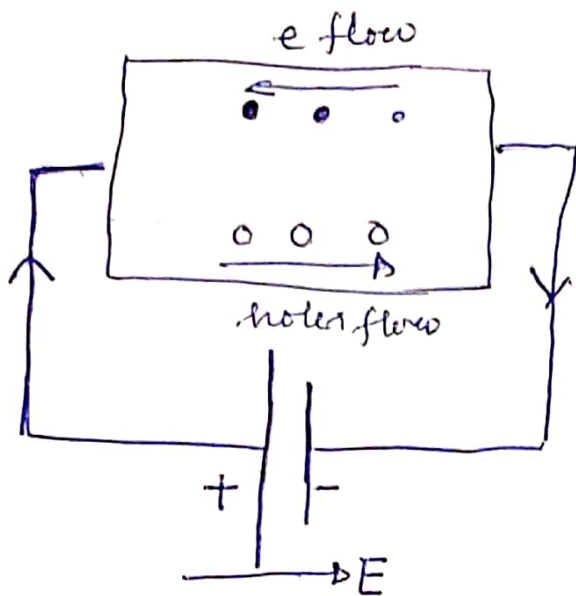
carries constitutes current.

conductivity  $\sigma = ne\mu_e + p e \mu_p$

$\mu_e$  = mobility of electron.  $\mu_p$  = hole

$\sigma = ne(\mu_n + \mu_p)$   $[n=p]$



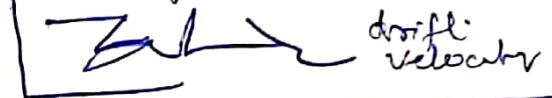


### Drift velocity

$$v_d \propto E$$

$$v_d = \mu E, \quad \mu = \frac{v_d}{E}$$

case with which  $e^-$  moves in the effect of applied external field.  
 \* After external field,  $e^-$  gets energy moves loose all energy with atom interaction again gets accelerated.



Density of states :- No. of <sup>density</sup> states per unit energy is defined as density of states

$$D(E) = dN/dE$$

$$E \rightarrow E + dE$$

$(dN) \rightarrow$  No. density of ~~energy~~ states  
 (No. of states per unit volume)

\* We are taking case of 3D solid.

in 2D -  $dN = \#$  of states / area

1D -  $dN = \#$  of states / length

3D -  $dN = \#$  of states / Volume

$$D(E) = \frac{1}{2\pi^2} \left( \frac{2m_e}{\hbar^2} \right)^{3/2} \sqrt{E} \quad \left[ \begin{array}{l} \text{(for 3D case only)} \\ \text{effective } m_e = \text{mass of electron} \end{array} \right]$$

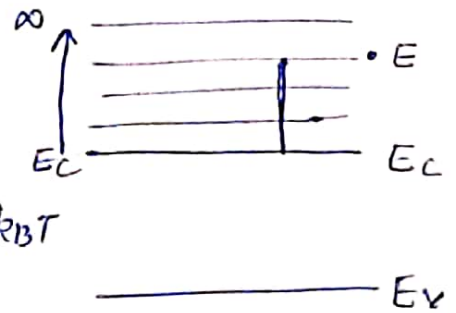
# of electron (charge carriers) in Conduction Band

$n = \#$  density of electron in conduction band

$$n = \int_{E_c}^{\infty} f_{FD} D(E) dE = \int_{E_c}^{\infty} f_{FD} D(E) dE$$

$$D(E) \rightarrow E \rightarrow \sqrt{E - E_c}$$

$$n = \int_{E_c}^{\infty} \frac{1}{1 + e^{(E-E_F)/k_B T}} \frac{1}{2\pi^2} \left( \frac{2me}{\hbar^2} \right)^{3/2} \sqrt{E-E_c} dE$$



for  $(E-E_F) \gg k_B T$ ,  $\frac{1}{1 + e^{(E-E_F)/k_B T}} \approx e^{-(E-E_F)/k_B T}$

$$n = \int_{E_c}^{\infty} \frac{e^{-(E-E_F)/k_B T}}{e} \left( \frac{1}{2\pi^2} \right) \left( \frac{2me}{\hbar^2} \right)^{3/2} (E-E_c)^{1/2} dE$$

$$n = \frac{e^{E_F/k_B T}}{2\pi^2} \left( \frac{2me}{\hbar^2} \right)^{3/2} \int_{E_c}^{\infty} e^{-E/k_B T} (E-E_c)^{1/2} dE$$

let  $E-E_c = x$ ;  $dE = dx$

$$n = \frac{e^{E_F/k_B T}}{2\pi^2} \left( \frac{2me}{\hbar^2} \right)^{3/2} \int_0^{\infty} \frac{e^{-E_c/k_B T - x/k_B T}}{e} x^{1/2} dx$$

$$n = \left( \frac{1}{2\pi^2} \right) \left( \frac{2me}{\hbar^2} \right)^{3/2} e^{(E_F-E_c)/k_B T} \int_0^{\infty} x^{1/2} e^{-x/k_B T} dx$$

Standard  
Integral

$$\int_0^{\infty} x^n e^{-\alpha x} dx = \frac{1}{\alpha^{n+1}} \Gamma(n+1)$$

$$\int_0^{\infty} x^{1/2} e^{-\alpha x} dx = \frac{\sqrt{\pi}}{2} (\alpha)^{-3/2}$$

$$\alpha = \frac{1}{k_B T} \quad n = \frac{1}{2}$$

$$n = \frac{1}{2\pi^2} \left( \frac{2me}{\hbar^2} \right)^{3/2} e^{(E_F-E_c)/k_B T} \frac{\sqrt{\pi}}{2} (k_B T)^{3/2}$$

$$n = \frac{1}{4} \left( \frac{2 m_e k_B T}{\pi \hbar^2} \right)^{3/2} e^{(E_F - E_c)/k_B T}$$

$$n = \frac{2}{2^3} \left( \frac{2 m_e k_B T}{\pi \hbar^2} \right)^{3/2} e^{(E_F - E_c)/k_B T}$$

$$n = 2 \left( \frac{m_e k_B T}{2 \pi \hbar^2} \right)^{3/2} e^{(E_F - E_c)/k_B T}$$

similarly

$$p = \int_{-\infty}^{E_v} D(E) (f_{FD})_{\hbar} dE$$

↓  
(1 - f<sub>FD</sub>)

$$D(E) = \frac{1}{2\pi^2} \left( \frac{2 m_h}{\hbar^2} \right)^{3/2} \sqrt{(E_v - E)}$$

$$p = 2 \left( \frac{m_h k_B T}{2 \pi \hbar^2} \right)^{3/2} e^{(E_v - E_F)/k_B T} \quad \text{* Position of Band gap}$$

since the  $n = p$  (for ~~extrinsic~~ semiconductor)

$$n = p$$

$$2 \left( \frac{m_e k_B T}{2 \pi \hbar^2} \right)^{3/2} e^{(E_F - E_c)/k_B T} = 2 \left( \frac{m_h k_B T}{2 \pi \hbar^2} \right)^{3/2} e^{(E_v - E_F)/k_B T}$$

$$\left( \frac{m_e}{m_h} \right)^{3/2} = e^{(E_v - E_F - E_F + E_c)/k_B T} = e^{(E_c + E_v - 2E_F)/k_B T}$$

$$\frac{(E_c + E_v - 2E_F)}{k_B T} = \frac{3}{2} \log \left( \frac{m_e}{m_h} \right); \quad E_c + E_v - 2E_F = \frac{3}{2} k_B T \log \left( \frac{m_e}{m_h} \right)$$



$$2E_f = (E_c + E_v) - \frac{3}{2} k_B T \log \left( \frac{m_e}{m_h} \right)$$

$$E_f = \frac{(E_c + E_v)}{2} - \frac{3}{4} k_B T \log \left( \frac{m_e}{m_h} \right)$$

Since  $m_h \neq m_e$  is insignificant  
Fermi level in an intrinsic  
SM may be considered as  
independent of temperature

$$m_e \approx m_h$$

$$E_f = \frac{E_c + E_v}{2}$$

\* Intrinsic semiconductor;  
fermi level lies in between conduction  
and valence band.  
~~\* not function of temperature~~

Law of Mass action

$$np = 2 \times 2 \left( \frac{m_e m_h k_B T}{2\pi \hbar^2} \right)^3 (m_e m_h)^{3/2} e^{(E_f - E_c + E_v - E_f)/k_B T}$$

$$np = 4 \left( \frac{k_B T}{2\pi \hbar^2} \right)^3 (m_e m_h)^{3/2} e^{-(E_c - E_v)/k_B T}$$

$$E_c - E_v = E_g$$

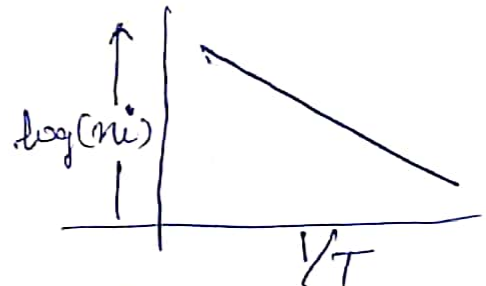
$$np = 4 \left( \frac{k_B T}{2\pi \hbar^2} \right)^3 (m_e m_h)^{3/2} e^{-E_g/k_B T}$$

$n = p = n_i$  (intrinsic semiconductor)

$$n_i = 2 \left( \frac{k_B T}{2\pi \hbar^2} \right)^{3/2} (m_e m_h)^{3/4} e^{-E_g/2k_B T}$$

$$n_i = n_i(T)$$

$$n_i = A T^{3/2} e^{-E_g/2k_B T}$$



$n_i$  mainly depends on exponential factor. I mean  
 $e^{-E_g/2k_B T}$  is dominating factor

## Conductivity of Intrinsic Semiconductor (Measurement of Band gap)

$$\sigma = \sigma_e + \sigma_h = n e \mu_e + p e \mu_p \quad n = p = n_i$$

$$\sigma = n_i e (\mu_e + \mu_p)$$

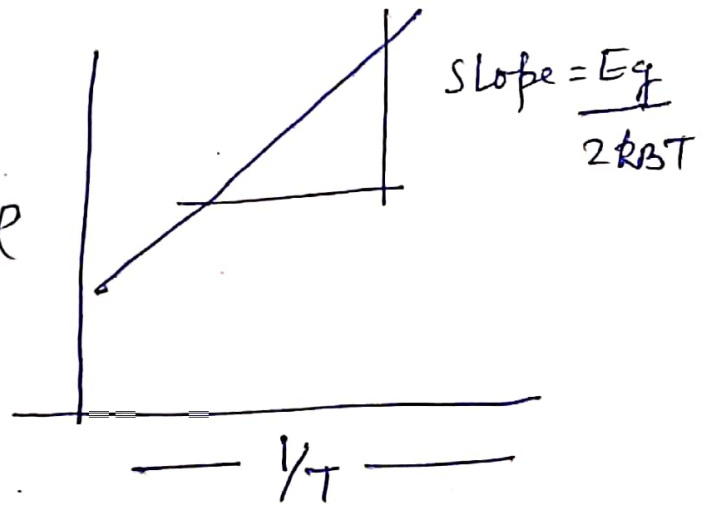
$$\sigma = \underbrace{e(\mu_e + \mu_p) A T^{3/2}}_{\sigma_0} e^{-E_g/2k_B T}$$

$$\sigma = \sigma_0 e^{-E_g/2k_B T}$$

Resistivity  $\rho = \frac{1}{\sigma}$

$$\rho = \rho_0 e^{+E_g/2k_B T}$$

$\log \rho$



$$\log \rho = \log \rho_0 + \frac{E_g}{2k_B} \left( \frac{1}{T} \right)$$

conductivity of intrinsic semiconductor increases with temperature which is reverse case to conductor.

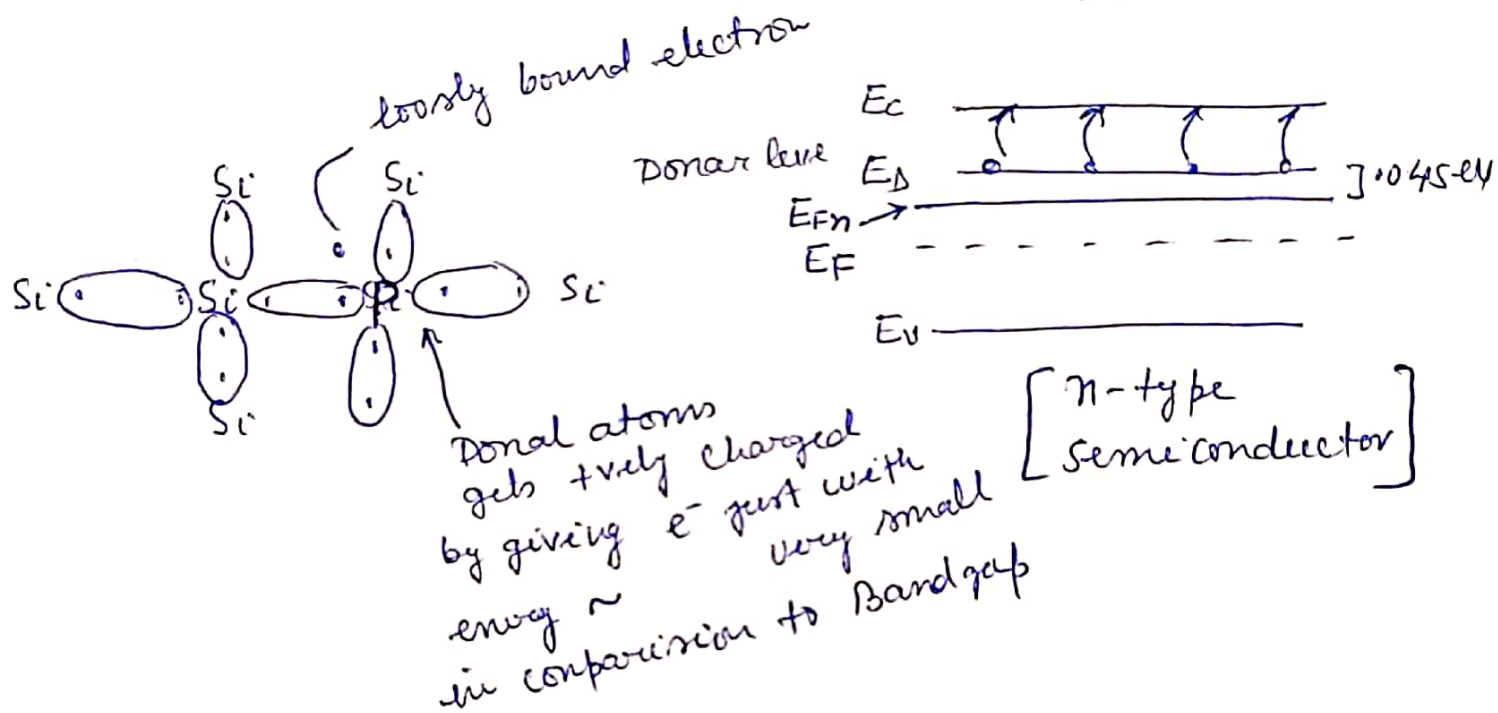


## Extrinsic Semiconductor (Doped Semiconductor)

Ge - Si (group IV element)

Add impurity during the growth of crystal it will provide extra electrons or holes.

Pentavalent Impurity (P, As, Sb; Phosphorous, Arsenic, Antimony)



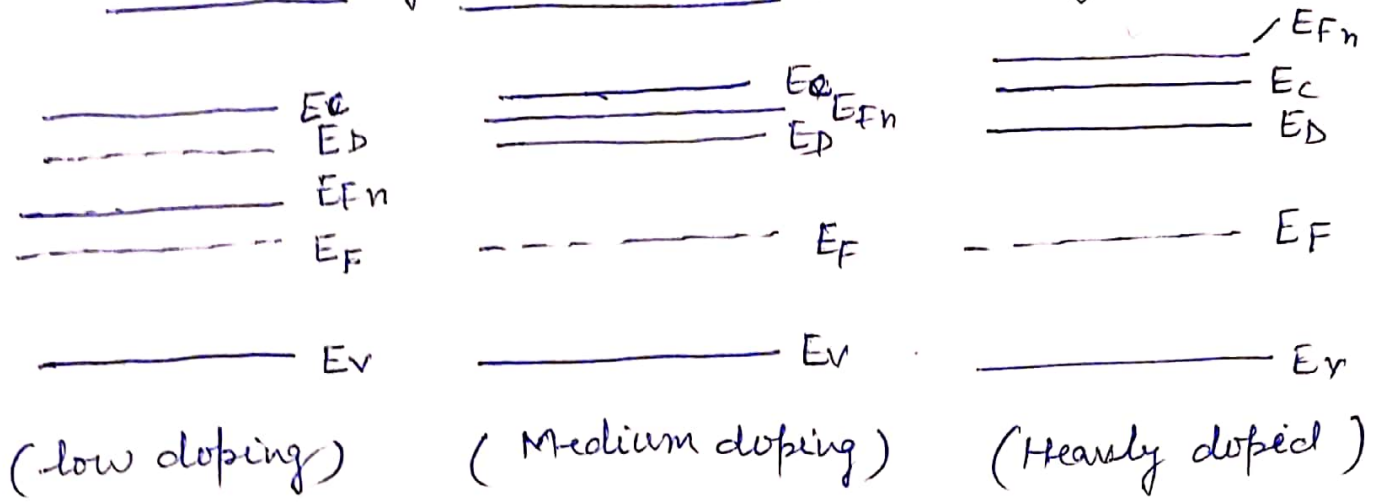
→ Donor impurity provides huge no. of free electrons with small energy ( $\sim 0.045 \text{ eV}$ ). This can be understood with the concept of Donor level close to conduction band. Position of Fermi level shift towards conduction band. Its position (actual) will depend upon the doping concentration.

Low doping →  $E_{Fn}$  between ( $E_F$  &  $E_D$ )

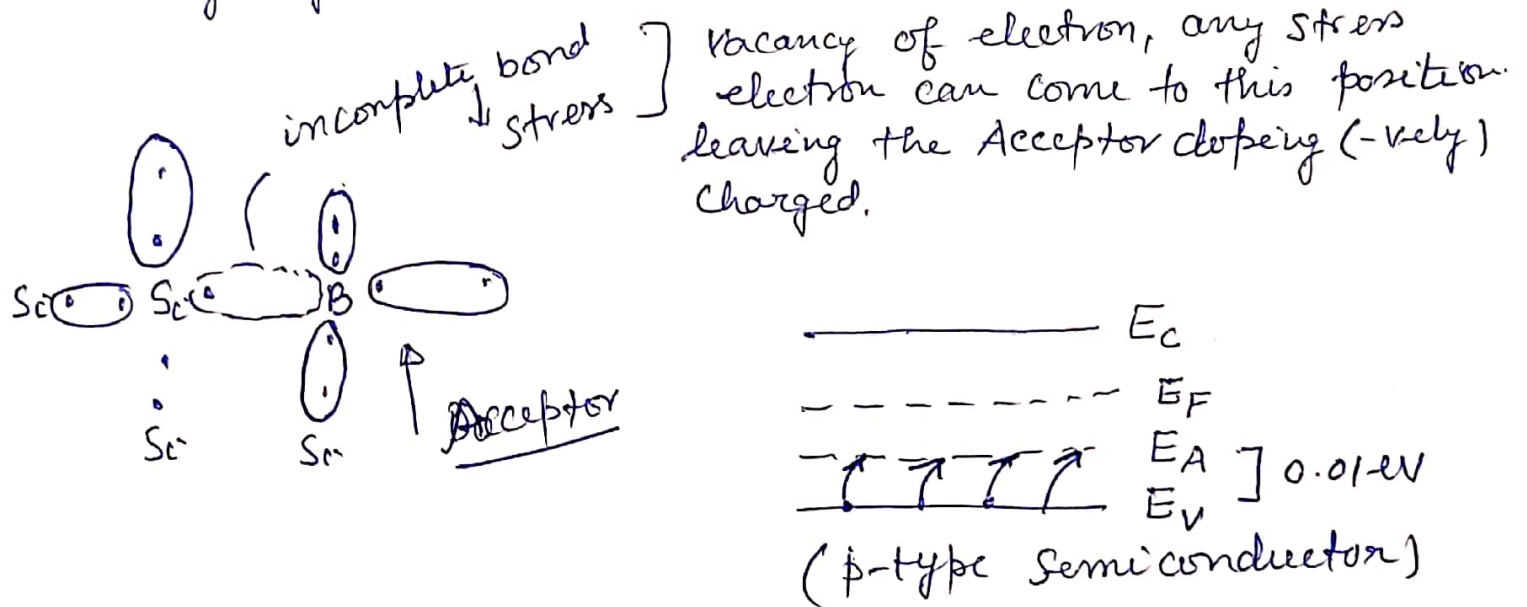
Medium doping →  $E_{Fn}$  between ( $E_D$  &  $E_C$ )

Heavy doping —  $E_{Fn}$  between (Inside the conduction band) equivalent to semiconductor  
care of laser diode. called population inversion conduction.

# Variation of Fermi-level with Doping Concentration



p-type semiconductor :- Addition of trivalent impurity during crystal formation provides excess holes [Al, B, Ga, In]



holes - Majority carrier } p-type semiconductor  
electron - Minority carrier }

electron - Majority carrier } n-type semiconductor  
hole - Minority carrier }

Variation of Fermi level with doping conc. follows the same pattern.

1. At what temperature we can expect a 10% prob that electron in silicon have an energy which is 1% above the Fermi level  $E_F = 5.5 \text{ eV}$

$$\frac{E - E_F}{E_F} = 1\% \quad , \quad E - E_F = 0.055 \text{ eV}$$

$$f_E = 0.1$$

$$0.1 = \frac{1}{1 + e^{(E - E_F)/k_B T}}$$

$$T = 290 \text{ K}$$

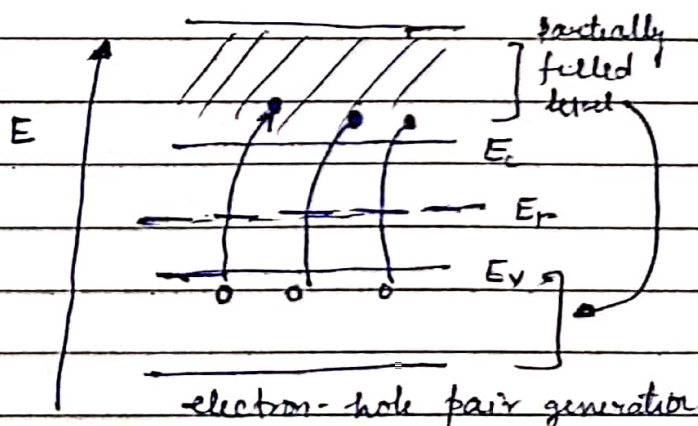
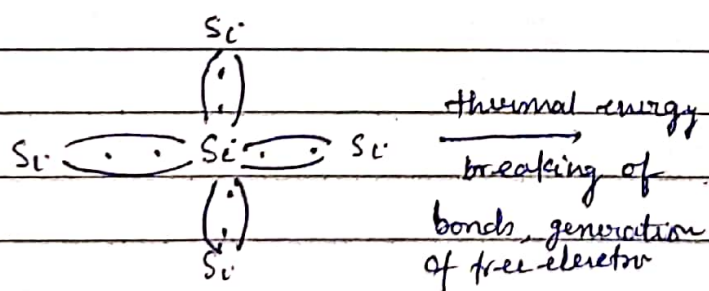
Valence band

At room Temp. (300K)  $\sim 1.5 \times 10^{16} \text{ m}^{-3}$

( $1.5 \times 10^{16} \text{ electron/m}^3$ ) - silicon.

in conduction band at room temp.

Intrinsic Semiconductor :- Group IV - element (Germanium, Silicon) (Ge, Si)



On applying electric field - electric hole - fictitious particle (+e) conductivity takes place. (mh)

$$\sigma = \mu_e n e + \mu_h p e$$

$n = \# \text{ of } e \text{ in conduction band}$

$p = \# \text{ density of holes in Valence band}$

$$\sigma = n(\mu_e + \mu_h)e$$

$$n = p$$